

PATENTSIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: VON AMMON ET AL 9

SERIAL NO.: 09/813,240

EXAMINER: J. MONDT

FAX COPY RECEIVED

APR 16 2002

FILED: MARCH 20, 2001

GROUP: 2826

TECHNOLOGY CENTER 2800

TITLE: SEMICONDUCTOR WAFER MADE FROM SILICON AND
METHOD FOR PRODUCING THE SEMICONDUCTOR WAFERSAMENDMENT IN RESPONSE TO FIRST OFFICE ACTIONATTN: BOX NON-FEE AMENDMENT
Assistant Commissioner of Patents
Washington, D.C. 20231

Dear Sir:

In response to the First Office Action dated January 16, 2002, please amend the above-identified patent application as follows:

IN THE CLAIMS:

Please cancel claim 1 without prejudice.

Please cancel claim 3 without prejudice, and please amend claim 2 to recite the features thereof.

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